

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP AFTER FINAL
)	
Jung-hyun Lee et al.)	Group Art Unit: 2811
)	
Application No.: 10/797,046)	Examiner: Ori NADAV
)	
Filed: March 11, 2004)	Confirmation No.: 4688
)	
For: METHOD FOR MANUFACTURING)	
OXIDE FILM HAVING HIGH)	
DIELECTRIC CONSTANT,)	
CAPACITOR HAVING DIELECTRIC)	
FILM FORMED USING THE)	
METHOD, AND METHOD FOR)	
MANUFACTURING THE SAME)	

RESPONSE UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated October 22, 2008, Applicants submit herewith a petition for one month extension of time extending the period for response from January 22, 2009 to February 22, 2009 and the following Amendments and Remarks.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this Response.

Remarks begin on page 3 of this Response.